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1765

PATENT
Attorney Docket No.: SAM-0256
Customer No.: 29344

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Sung-Un Kwean, *et al.* Examiner: Umez Eronini, Lynette T.
Serial No.: 09/993,832 Group Art Unit: 1765
Filing Date: November 6, 2001
Title: ETCHING GAS COMPOSITION OF SILICON OXIDE AND METHOD OF
ETCHING SILICON OXIDE USING THE SAME

CERTIFICATE OF MAILING UNDER 37 C.F.R. § 1.8

I hereby certify that this correspondence is being deposited with the United States Post Office as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450.

3-4-04

Date

Vanessa Marakas
Vanessa Marakas

Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following:

1. Response to Restriction Requirement mailed on February 6, 2004; and
2. Return Postcard.

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

Date: March 4, 2004
MILLS & ONELLO LLP
Eleven Beacon Street, Suite 605
Boston, MA 02108
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Anthony P. Onello, Jr.
Anthony P. Onello, Jr.
Registration Number 38,572
Attorney for Applicant



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RESPONSE TO RESTRICTION REQUIREMENT

Sir:

In response to the Restriction Requirement dated February 6, 2004 in the above-referenced patent application, the Applicants hereby elect Group II, including claims 9-22, without traverse.

Respectfully submitted,

Date: March 4, 2004
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